

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10052244	01/23/2002	438		2812	
**APPLICANTS: Sasaki Katsuhito					
**CONTINUING DATA VERIFIED:					
** FOREIGN APPLICATIONS VERIFIED: JAPAN 250752/2001 08/21/2001					
PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>		ATTORNEY DOCKET NO	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no				OKI 295	
35 USC 119 condition met <input type="checkbox"/> yes <input type="checkbox"/> no					
Verified and Acknowledged Examiners initials					
TITLE : Method of manufacturing lateral double-diffused metal oxide semiconductor device					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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